

PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q91745

Takayuki MARUYAMA, et al.

Appln. No.: 10/558,369

Group Art Unit: 1792

Confirmation No.: 4169

Examiner: Felisa Carla HITESHEW

Filed: June 20, 2006

For: SILICON CARBIDE SINGLE CRYSTAL AND METHOD AND APPARATUS FOR
PRODUCING THE SAME

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the interview conducted on
February 14, 2008:

REMARKS

An Examiner's Interview Summary Record (PTO-413) was attached with the Notice of
Allowance dated February 22, 2008.

The interview was initiated by the Examiner. Therefore, no further recordation by the
Applicant is believed to be required.

During the interview, the following was discussed:

1. Brief description of exhibits or demonstration: No
2. Identification of claims discussed: Claims 31-33
3. Identification of art discussed: No

4. Identification of principal proposed amendments: cancel Claims 31-33
5. Brief Identification of principal arguments: cancel Claims 31-33 to place the present application in condition for allowance.
6. Indication of other pertinent matters discussed: No
7. Results of Interview: Agreement was reached

It is respectfully submitted that the instant STATEMENT OF SUBSTANCE OF INTERVIEW complies with the requirements of 37 C.F.R. §§1.2 and 1.133 and MPEP §713.04.

It is believed that no petition or fee is required. However, if the USPTO deems otherwise, Applicant hereby petitions for any extension of time which may be required to maintain the pendency of this case, and any required fee, except for the Issue Fee, for such extension is to be charged to Deposit Account No. 19-4880.

Respectfully submitted,



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Date: March 19, 2008